

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:	. )	<b>CONFIRMATION NO.: 3236</b>		
Takayuki TOSHIMA, et al.	)			
U.S. Serial No.: 10/052,534	)	Group Art Unit: 1746		
Filed: January 23, 2002	)	Examiner: Michail Kornakov		

SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD For:

## SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449). This Information Disclosure Statement, together with a concurrently filed reply to an Office Action, constitutes a "submission" required as part of a Request for Continued Examination (RCE) as filed herewith.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

> Respectfully submitted, SMITH, GAMBRELL & RUSSELL, LLP

Michael A. Makuch, Reg. No. 32,263

1850 M Street, N.W., Suite 800 Washington, D.C. 20036 Telephone: (202) 263-4300

Fax: (202) 263-4329

Date: January 12, 2007

INFORMATION DISCLOSURE STATEMENT					ATTY. DOCKET 033082 M 115		SERIAL NO. 10/052,534	
				APPLICANTS	APPLICANTS:			
					Takayuki TOSHIMA, et al.			
JAN 1 2 2007 *  U.S. PATENT DOCUMENT DATE				FILING DATE January 23, 2002		GROUP ART UNIT 1746		
Ten.	ADEMAS		U.S. PATENT DO	CUMENTS				
*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIA E	
	AA							
	AB							
	AC			.,,,,				
	AD							
	AE							
	AF							
· · · · · · · · · ·	AG							
			FOREIGN PATENT [	OCUMENTS				
*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANS.	
	AH	2000-150439	05-30-2000	JP			Abstract	
	Al	08-130202	05-21-1996	JP			Abstract	
	AJ	61-098351	05-16-1986	JP			Abstract	
,	AK							
	ОТН	HER INFORMAT	ION (Including Author	, Title, Date, Pertiner	nt Pages, Etc	.)		
	AL					,		
	AM						·	
	AN							
	AO						8	
	AP							
EXAMINER:				DATE CONSIDERE	D.			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.